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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masatake Nukui et al.

Serial No. 10/825,526

Group Art Unit: 2882

Filed: April 15, 2004

Examiner: Artman, Thomas R.

For: X-RAY CT SYSTEM AND BEAM-HARDENING POST-PROCESSING METHOD

CERTIFICATE OF MAILING

I certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 29, 2005.

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STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

The above-identified patent application was filed on April 15, 2004. Applicants respectfully request a status inquiry on the above-identified patent application. A copy of this request is enclosed for the purpose of reporting the results of the status inquiry.

Respectfully submitted,

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